## Bhurendra Singh Deputy Registrar

## **CORRIGENDUM**

## E-Tender Notice No. F5(2518)ST/MNIT/PHY/2019

The due date of opening of tender for "Chemical Vapor Deposition (CVD) system with flow control for Gases" which was scheduled to be opened on 13.03.2020 as further been extended upto <u>26.03.2020 (Thursday</u>). The tender can be submitted till 02.00PM on 26.03.2020 and the same will be opened on the same day at 3.00 PM. for details visit: www.mnit.ac.in and <u>https://eprocure.gov.in/epublish/app</u>

However, all other terms & conditions of our NIT will remain unchanged

Deputy Registrar (Store & Purchase)